

Handbook of Ion Beam Processing Technology

HANDBOOK OF ION BEAM PROCESSING TECHNOLOGY

**Principles, Deposition,
Film Modification and Synthesis**



**Edited by
Jerome J. Cuomo, Stephen M. Rossnagel
and
Harold R. Kaufman**

NOYES PUBLICATIONS

[Handbook of Ion Beam Processing Technology_下载链接1](#)

著者:Cuomo, Jerome J./ Rossnagel, Stephen M. (EDT)

出版者:

出版时间:1990-1

装帧:

isbn:9780815511991

This book deals with ion beam processing for basic sputter etching of samples, sputter deposition of thin films, the synthesis of material in thin film form, and the modification of the properties of thin films.

作者介绍:

目录:

[Handbook of Ion Beam Processing Technology_下载链接1](#)

标签

deposition

beam

Ion

评论

[Handbook of Ion Beam Processing Technology_下载链接1](#)

书评

[Handbook of Ion Beam Processing Technology_下载链接1](#)